

Attorney Docket No.: DAIN:740

July 8, 2003

PARKHURST & WENDEL, L.L.P.

1421 Prince Street, Suite 210

Alexandria, Virginia 22314-2805

Telephone: (703) 739-0220

MAIL STOP - PATENT APPLICATION COMMISSIONER FOR PATENTS P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Transmitted herewith for filing under 37 C.F.R. §1.53(b) is the patent application of

Date:

Inventor(s): Masaaki KURIHARA, Shinjuku-Ku, Tokyo-To, Japan; and Nobuhito TOYAMA, Shinjuku-Ku, Tokyo-To, Japan.

For: PHASE MASK FOR FORMING DIFFRACTION GRATING, METHOD FOR MANUFACTURING THE PHASE MASK, AND METHOD FOR FORMING DIFFRACTION GRATING

Enclosed are:

- [x] Application Data Sheet.
- [x] Five (5) sheets of drawings, Figures 1A-5C.
- [] An Assignment of the invention to <u>DAI NIPPON PRINTING CO.</u>, <u>LTD.</u>, <u>1-1</u>, <u>Ichiqaya-Kaqa-cho 1-Chome</u>, <u>Shinjuku-Ku</u>, <u>Tokyo-To</u>, <u>Japan</u>.
- [] Certified copy of <u>Japanese</u> application No. 2002-200558 filed July 9, 2002.
- [] A Declaration and Power of Attorney.
- [x] This application is not entitled to small entity status.
- [] A Preliminary Amendment is enclosed.
- [] An Information Disclosure Statement.

[x] The Verified English-Language Translation, executed Declaration and Assignment and full filing fees will follow in due course.

750.00
0.00
0.00
_

- [] Our Check No. \_\_\_\_\_ in the amount of the total filing fee is enclosed. However, if the check is missing or insufficient, the Commissioner is authorized to charge any additional fees which may be required, or credit any overpayment, to our Deposit Account No. -----
- [] The Commissioner is hereby authorized to charge payment of the following fees during the pendency of this application or credit any overpayment to our Deposit Account No. ----: any patent application processing fees under 37 CFR 1.17; and any filing fees under 37 CFR 1.16 for presentation of extra claims.

Respectfully submitted,

PARKHURST & WENDEL, L.L.P.

Roger W. Parkhurst

Registration No. 25,177